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S/N 10/634,174

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Leonard Forbes	Examiner:	Joannie A. Garcia
Serial No.:	10/634,174	Group Art Unit:	2823
Filed:	August 5, 2003	Docket No.:	1303.102US1
Title:	STRAINED Si/SiGe/SOI ISLANDS AND PROCESSES OF MAKING SAME		

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Office Action mailed on July 27, 2004. Please amend the above-identified patent application as follows.

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